For: Direct Detection Of Dielectric Etch System ... Malfunctions
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## FIG 1A

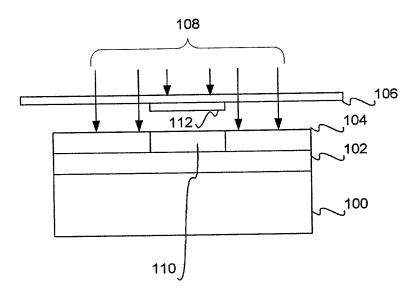
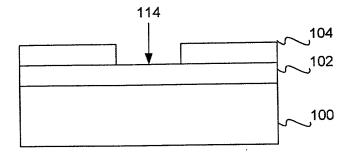


FIG 1B



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FIG 1C

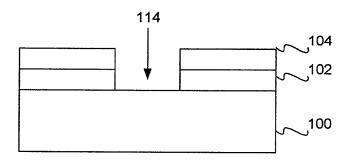
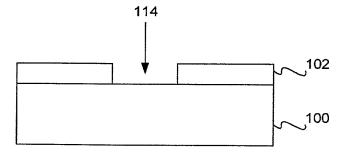
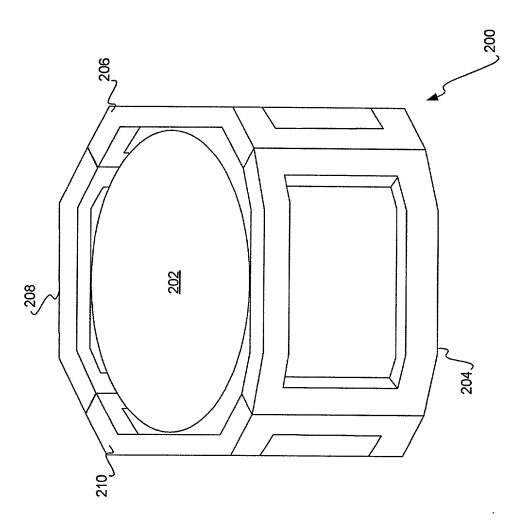


FIG 1D



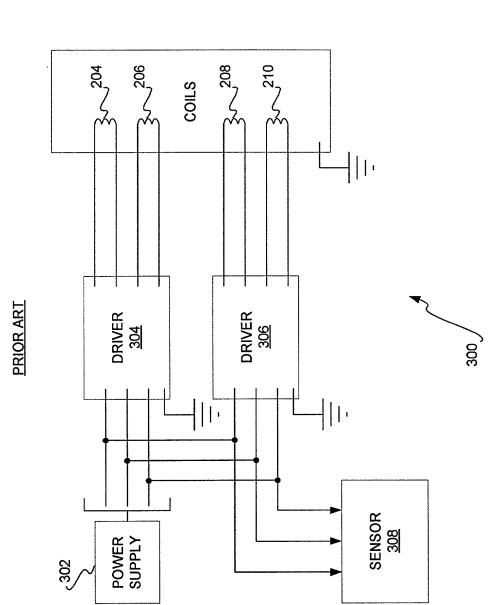
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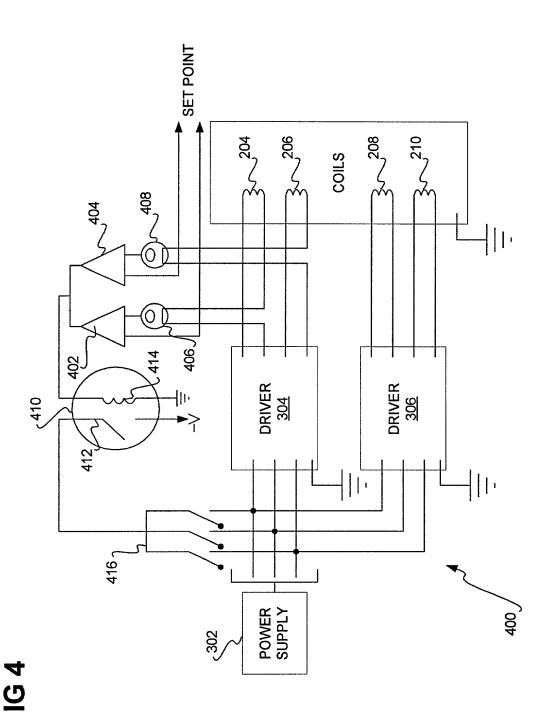


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